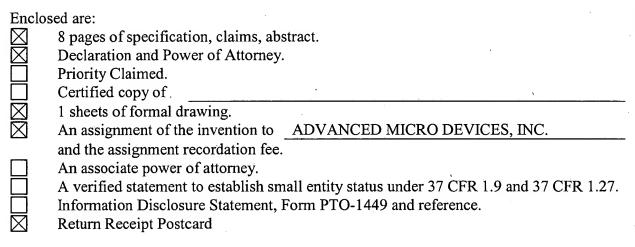
Docket No.: 50432-601

UTILITY PATENT APPLICATION UNDER 37 CFR 1.53(b)

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir:

Transmitted herewith for filing is the patent application of:

INVENTOR: Minh Van NGO, Mark RAMSBEY, Tazrien KAMAL, Pei Yuan GAO FOR: PECVD SILICON-RICH OXIDE LAYER FOR REDUCED UV CHARGING



The filing fee has been calculated as shown below:

	NO. OF CLAIMS		EXTRA CLAIMS	RATE	AMOUNT
Total Claims	19	-20	0	\$18.00	\$0.00
Independent Claims	2	-3	0	\$84.00	\$0.00
			Multiple D	ependent Claim(s)	\$0.00
Basic Fee				\$750.00	
Total of Above Calculations			\$750.00		
Less ½ for Small Entity				\$0.00	
	123		Assignmen	t & Recording Fee	\$40.00
		108		Total Fee	\$790.00



10/617451

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Respectfully submitted,

MCDERMOTT, WILL & EMERY

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Date: July 11, 2003